## APR 2 2 2005 U

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e application of: Hemker et al.

Attorney Docket No.: LAM1P128D1

Application No.: 10/618,289

Examiner: ANDERSON, MATTHEW A.

Filed: July 11, 2003

Group: 1765

Title: MATERIALS AND GAS CHEMISTRIES

Confirmation No.: 4379

FOR PROCESSING SYSTEMS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on April 20, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Susan W. Xu

## INFORMATION DISCLOSURE STATEMENT BEFORE FINAL ACTION OR NOTICE OF ALLOWANCE (37 CFR §§ 1.56 AND 1.97(c))

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449 may be material to examination of the above-identified patent application. Applicants submit the list of these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application. The above-identified application is a Divisional Application of prior application U.S. Patent Application No. 09/440,794. This prior application is being relied upon for an earlier filing date under 35 U.S.C. § 120. Because the listed references were either cited by the PTO, or submitted to the PTO in the prior application, under 37 CFR § 1.98(d) Applicants submit that copies need not be provided. Please note that references (marked with an \*) are enclosed herewith since these references were not cited during the prosecution of the above-mentioned application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that this reference indeed constitutes prior art.

04/25/2005 BABRAHA1 00000013 10618289

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This Information Disclosure Statement is being filed after the mailing date of the first Office Action on the merits, or after three months of the filing date of this application, whichever event occurred last, but it is believed before the mailing date of either: (i) a final action under §1.113 or (ii) a notice of allowance under §1.311, whichever occurs first.

Accompanying this Information Disclosure Statement is
the fee set forth in 37 CFR 1.17(p).

If fees are due, enclosed is our Check No. 26104 for \$180.00 in payment of the Information Disclosure Statement Fee. If it is determined that any additional fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. LAM1P128D1).

Respectfully submitted, BEYER WEAVER & THOMAS, LLP

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Form 1449 (Modified)

**Information Disclosure Statement By Applicant** 

(Use Several Sheets if Necessary)

Atty Docket No. LAM1P128D1

Applicant:

Hemker et al. Filing Date

July 11, 2003

Application No.:

10/618,289

10/010,209

Group 1765

**U.S. Patent Documents** 

| Examiner |      |            |          |                    |       | Sub-  | Filing   |
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| Examiner |      |            |          | Date Considered    |       |       |          |

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

| Form 1449 (Modified)              | Atty Docket No. | Application No.: |
|-----------------------------------|-----------------|------------------|
|                                   | LAM1P128D1      | 10/618,289       |
| Information Disclosure            | Applicant:      |                  |
| Statement By Applicant            | Hemker et al.   |                  |
|                                   | Filing Date     | Group            |
| (Use Several Sheets if Necessary) | July 11, 2003   | 1765             |

Foreign Patent or Published Foreign Patent Application

| Foreign Fatent of Fublished Foreign Fatent Application |     |               |             |               |       |       |       |        |
|--|-----|---------------|-------------|---------------|-------|-------|-------|--------|
| Examiner   |     | Document      | Publication | Country or    |       | Sub-  | Trans | lation |
| Initial  | No. | No.           | Date        | Patent Office | Class | class | Yes   | No     |
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| Examiner |     |   |  |  |
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|          | C3* | Office Action dated March 28, 2001 for U.S. Application No. 09/439,661, entitled "PLASMA PROCESSING SYSTEMS," filed on November 15, 1999, now U.S. Patent No. 6,341,574 B1.       |  |  |
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| Examiner |     | Date Considered   |  |  |

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.